

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Terry L. Gilton and Li Li

Art Unit: 2814

Application No. 09/321,518

Filed: May 27, 1999

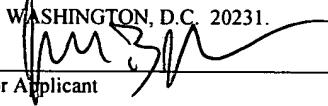
For: SEMICONDUCTOR FABRICATION
APPARATUS

Examiner: B. Souw

Date: December 5, 2002

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on December 5, 2002 as First Class Mail in an envelope addressed to:
BOX NON-FEE AMENDMENT COMMISSIONER FOR
PATENTS, WASHINGTON, D.C. 20231.


Attorney for Applicant
TRANSMITTAL LETTER

BOX NON-FEE AMENDMENT
COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

Enclosed is an Amendment for the above application. The fee has been calculated as shown below.

CLAIMS AS AMENDED

For	No. after amendment	No. paid for previously	Present Extra	Rate	Fee
Total Claims	18	- 46*	= 0	\$18.00	\$ 0.00
Indep. Claims	8	16**	= 0	\$84.00	\$ 0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

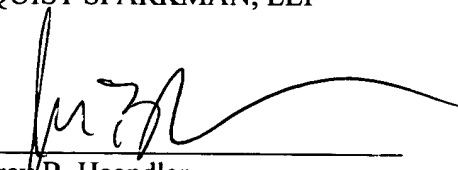
* greater of twenty or number for which fee has been paid.

** greater of three or number for which fee has been paid.

- ☒ No additional fee is required.
- ☒ Please charge any additional fees that may be required in connection with filing this amendment and any extension of time, or credit any overpayment, to Deposit Account No. 02-4550. A copy of this sheet is enclosed.
- ☒ Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

By: 
Jeffrey B. Haendler
Registration No. 43,652

One World Trade Center, Suite 1600
121 S.W. Salmon Street
Portland, Oregon 97204
Telephone: (503) 226-7391
Facsimile: (503) 228-9446
cc: Docketing

2814
RECEIVED
DEC 16 2002
TECHNICAL CENTER 2000



PATENT

Attorney Reference Number 6047-51973

Application Number 09/321,518

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Terry L. Gilton and Li Li

Art Unit: 2814

Application No. 09/321,518

Filed: May 27, 1999

For: SEMICONDUCTOR FABRICATION
APPARATUS

Examiner: Wai-Sing Louie

Date: December 5, 2002

BOX NON-FEE AMENDMENT
COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on December 5, 2002 as First Class Mail in an envelope addressed to: BOX NON-FEE AMENDMENT, COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

Attorney for Applicant

RESPONSE

This paper responds to the Office action dated September 18, 2002.

REMARKS

Claims 39-56 are pending in the present application. Reconsideration is requested.

Claims 39-41, 43-48, and 50-56 are rejected under 35 U.S.C. § 102(e) as allegedly being anticipated by U.S. Patent No. 5,762,755 to McNeilly et al. Claims 42 and 49 are rejected under § 103(a) as allegedly being unpatentable over McNeilly in view of U.S. Patent No. 4,795,497 to McConnell et al., and U.S. Patent No. 4,946,549 to Bachman et al. Applicants continue to traverse each of these objections.

McNeilly is distinguishable from the claims of the present application because McNeilly does not disclose or suggest (1) a liquid solvent layer on a wafer that serves as a transport medium for a reactive gas or (2) a liquid solvent layer that is inert to or non-chemically reactive with the surface of a wafer, as recited in the present claims.